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	Application No.	Applicant(s)		
Notice of Allowability	10/676,094	NISHIDA ET AL.		
	Examiner	Art Unit		
	Felisa C. Hiteshew	1722		
The MAILING DATE of this communication apperation apperation all claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIOF the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication GHTS. This application is subject to	olication. If not include will be mailed in due	ed course. THIS	
1. A This communication is responsive to the amendment filed of	on July 5, 2005.			
2. X The allowed claim(s) is/are 1-22.				
 Acknowledgment is made of a claim for foreign priority unally All b) ☐ Some* c) ☐ None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 	e been received. e been received in Application No cuments have been received in this of this communication to file a reply	national stage applica		
4. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give	itted. Note the attached EXAMINER es reason(s) why the oath or declara	'S AMENDMENT or Nation is deficient.	OTICE OF	
 CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1) 	son's Patent Drawing Review (PTO s Amendment / Comment or in the C	Office action of	e back) of	
each sheet. Replacement sheet(s) should be labeled as such in t	the header according to 37 CFR 1.121(d).		
6. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT	sit of BIOLOGICAL MATERIAL r FOR THE DEPOSIT OF BIOLOGIC	must be submitted. AL MATERIAL.	Note the	
Attachment(s)	5. Notice of Informal F	Patent Application (PT	O-152)	
 Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948) 	6. ☑ Interview Summary		- · - -/	
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Mail Da	te <u>see attached paper</u>	Ţ.	
Paper No./Mail Date 4. Examiner's Comment Regarding Requirement for Deposit		8. Examiner's Statement of Reasons for Allowance		
of Biological Material	9.	Félisa C. Hiteshew Primary Examiner Art Unit: 1722	letho	

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Priority

1. Receipt is acknowledged of papers submitted under 35 U.S.C. 119(a)-(d), which papers have been placed of record in the file.

EXAMINER'S AMENDMENT

2. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Damond E. Vadnais on July 19, 2006.

The application has been amended as follows:

In the claims: Please cancel non-elected claims 23-33.

Allowable Subject Matter

- 3. Claims 1-22 are allowed.
- 4. The following is an examiner's statement of reasons for allowance: The most relevant prior art of reference is that of U.S. Patent No. 6,391,108 B2 (Nishida, et al). However, it does not teach nor fairly suggest singularly or in any combination thereof a LPE method for a silicon crystal, in which a silicon crystal is grown on a substrate by immersing the substrate in a solvent or allowing the substrate to contact the solvent, comprising the step of: supplying a gas containing at least one of a raw material and a dopant to the solvent after at least a part of the gas is decomposed by application of energy to the gas.

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Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the Examiner should be directed to Felisa Hiteshew whose telephone number is (571) 272-1463. The examiner can normally be reached on Mondays through Thursday from 5:30 AM to 4:00 PM with Fridays off.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Yogendra Gupta, can be reached on (571) 272-1316. The fax phone number for the organization where this application or proceeding is assigned is (571) 273-1463.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system. see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866- 217-9197 (toll-free).

FELISA HITESHEW PRIMARY EXAMINER

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